

Appl. no. 10/772,970
IDS dated December 11, 2006

12/11/06

Modified Form PTO/SB/08A

INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)		<i>Complete If Known</i>			
		Application Number	10/772,970		
		Filing Date	February 5, 2004		
		First Named Inventor	Miller		
		Group Art Unit	2829		
		Examiner Name	Emily Y. Chan		
Sheet	1	of	1	Attorney Docket No.	P199-US

U.S. PUBLISHED PATENT DOCUMENTS							
Examiner Initials*	Cite No. ¹	U.S. Patent Document		Name of Patentee or Applicant	Publ./Issue Date	Related [#]	Copy Enclosed
		Number	Kind Code ²				
EC	1.	5,216,361		Akar et al.	6/1/1993		No***
EC	2.	5,420,796		Weling et al.	5/30/1995		No***

Examiner Signature	<i>Emily Chan</i>	Date Considered	<i>2/1/07</i>
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* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication

¹Unique citation designation number. ²See attached Kinds of U.S. Patent Documents. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

** Reference cited in parent application US Serial No. ___. 37 CFR § 1.98(d)

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& Notice dated October 19, 2004 by Deputy Commissioner for Patent Examination Policy waiving requirement to file copies of pending US patent applications if the applications are stored in the USPTO's IFW system.

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